Customer No. 20,995

Docket No.: ASMMC.032DV1

INFORMATION DISCLOSURE STATEMENT

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Hujanen et al.

App. No

10/781,574

Filed

Febuary 17, 2004

For

METHOD OF DEPOSITING THIN FILMS

FOR MAGNETIC HEADS

Examiner

Kevin M. Bernatz

Art Unit

1773

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 3 references to be considered by the Examiner. Also enclosed are 2 non-patent literature references as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R.§ 1.97(e)(2)

I hereby certify that no item of information contained in this Statement was cited in a communication from a foreign Patent Office in a counterpart foreign application, or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

By:

Adeel S. Akhtar

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Attorney of Record

Customer No. 20,995

(415) 954-4114

| | Application No. | 10/781,574 |
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| INFORMATION DISCLOSURE | Filing Date | February 17, 2004 |
| STEATEMENT BY APPLICANT | First Named Inventor | Hujanen et al. |
| O PIENCIAL DI VILLEICVIAL | Art Unit | 1773 |
| (Multiple sheets used when necessary) | Examiner | Kevin M. Bernatz |
| 11 5 2005 ₩ SHEET 1 OF 1 | Attorney Docket No. | ASMMC.032DV1 |

| TEN. | U.S. PATENT DOCUMENTS Pages, Columns, Lines Where | | | | |
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| Examiner Initials | Cite No. | Document Number Number - Kind Code (if known) Example: 1,234,567 B1 | Publication Date MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear |
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| NON PATENT LITERATURE DOCUMENTS | | | |
|---------------------------------|-------------|---|----------------|
| Examiner Initials | Cite No. | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ¹ |
| | | "ALD technology is in the process of taking off ASAP," www.micromagazine.com, 2005, 5 pages. | |
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Examiner Signature

Date Considered

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.